

<b>Notice of References Cited</b>	Application/Control No. 10/789,870	Applicant(s)/Patent Under Reexamination MAEGAWA ET AL.	
	Examiner Sylvia R. MacArthur	Art Unit 1763	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,647,642	11-2003	Kamikawa et al.	34/490
*	B	US-6,575,689	06-2003	Harris et al.	414/416.03
*	C	US-5,485,644	01-1996	Shinbara et al.	15/21.1
	D	US-			
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	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	S					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	English Translation of JP 11-268827. Taken from www19.ipdl.ncipi.go.jp
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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